

FORM PTO-1449 (SUBSTITUTE)

U.S. DEPARTMENT OF COMMERCE
PATENT AND TRADEMARK OFFICEOIPF
SEP 14 2001
INFORMATION DISCLOSURE
STATEMENT BY APPLICANT

37 CFR 1.98(b))

Attorney Docket No.:
GR 97 P 2734Applic. No.
09/161,196

Applicant

Frank Hintermaier

Filing Date
September 25, 1998Group Art Unit
2811

U.S. PATENT DOCUMENTS

EXAMINER INITIALS		PATENT NO.	DATE	PATENTEE	CLASS	SUB CLASS	FILING DATE
	A						
	B						
	C						
	D						
	E						
	F						
	G						
	H						
	I						

FOREIGN PATENT DOCUMENT

		DOCUMENT NO.	DATE	COUNTRY	CLASS	SUB CLASS	TRANSL. YES NO
<i>ca</i>	J	196 49 684 C1	09/11/97	Germany			X
<i>ca</i>	K	0 726 600 A2	08/14/96	Europe			X
	L						
	M						
	N						

OTHER DOCUMENTS (Including Author, Title, Date, Pertinent Pages, etc.)

<i>ca</i>	O	R. L. Ripley: "The Preparation And Properties Of Some Transition Phosphides", Journal of the Less-Common Metals, Vol.4, 1962, pp. 496-503;
<i>ca</i>	P	I.M. Watson et al.: "Chromium-phosphorus films deposited by the pyrolysis of an organometallic precursor", Thin Solid Films, Vol. 196, No. 1, February 1, 1991, pp. L21-L24

EXAMINER

my

DATE CONSIDERED

10-19-01

EXAMINER: Initial if citation considered, whether or not citation is in conformance with MPEP 609; Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.

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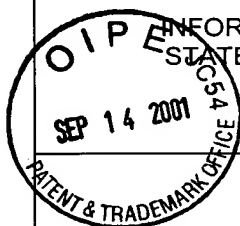
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OTHER DOCUMENTS (Including Author, Title, Date, Pertinent Pages, etc.)

<i>an</i>	O	S. Motojima et al.: "Chemical vapour growth of HfP whiskers and their properties", Journal of materials Science, Vol. 31, 1996, pp. 5709-5715
<i>an</i>	P	T. Suren Lewkebandara et al.: "Precursor for the Low-Temperature Deposition of Titanium Phosphide Films", Chem. Mater., 1995, No. 7, pp. 1053-1054

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an

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